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O I P E
JUN 29 2004
OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): HIMI et al.

Application No.: 10/656,326

Filed: September 8, 2003

Title: SEMICONDUCTOR DEVICE AND
METHOD FOR MANUFACTURING
THE SAME

Attorney Docket No.: 01-463

Group Art Unit: 2811

Examiner: NGUYEN, Cuong Quang

Commissioner for Patents
Arlington VA 22202

June 29, 2004

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to a Restriction Requirement mailed on June 1, 2004 in connection with the above application, Applicant hereby elects Invention II (claims 14 – 37, drawn to a method of making a semiconductor device) without traverse.

Examination of the present application in view of the above election is respectfully requested.

Please charge any necessary fees to Deposit Account 50-1147.

Respectfully submitted,



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